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SERIAL NUMBER 10/715,267	FILING DATE 11/17/2003 RULE	CLASS 156	GROUP ART UNIT 1763	ATTORNEY DOCKET NO. 2269-4375.1US (99- 1029.01)
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APPLICANTS

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**** CONTINUING DATA *******

This application is a DIV of 09/912,982 07/25/2001 PAT 6,863,771

*JM***** FOREIGN APPLICATIONS ********None JM***IF REQUIRED, FOREIGN FILING LICENSE GRANTED**

** 03/02/2004

Foreign Priority claimed	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	TX	DRAWING 7	CLAIMS 31	CLAIMS 2
Verified and Acknowledged <i>JM</i>	Examiner's Signature <i>JM</i> Initials <i>JM</i>				

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TITLE

Methods for polishing semiconductor device structures by differentially applying pressure to substrates that carry the semiconductor device structures

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT RECEIVED 968	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue)
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